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PATENT APPLICATION

**RESPONSE UNDER 37 CFR §1.116
EXPEDITED PROCEDURE
TECHNOLOGY CENTER ART UNIT 1765**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Makoto IIDA et al.

Application No.: 09/869,912

Filed: July 9, 2001

For: **SILICON SINGLE CRYSTAL WAFER AND PRODUCTION METHOD THEREOF
AND SOI WAFER**

Group Art Unit: 1765

Examiner: R. Kunemund

Docket No.: 110051

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AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the July 14, 2003 Office Action, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.

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